

Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 06618-424001	Application No. 09/532,461
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Marc A. Nicolet et al.	
		Filing Date March 22, 2000	Group Art Unit 1775

<b>U.S. Patent Documents</b>							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

<b>Foreign Patent Documents or Published Foreign Patent Applications</b>							
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation Yes      No
	AL						
	AM						
	AN						
	AO						
	AP						

<b>Other Documents (include Author, Title, Date, and Place of Publication)</b>							
Examiner Initial	Desig. ID	Document					
<i>MN</i>	AQ	Pisch et al., "Thermodynamic calculations offer insight in the stability of materials; the annealing behavior of amorphous Ru-Si-O and Ir-Si-O thin films", <u>Calphad.</u> , Vol. 25, No. 4, pp. 639-644 (2001)					
	AR						
	AS						
	AT						

Examiner Signature <i>Marc A. Nicolet</i>	Date Considered 6/29/05
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	